

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

BYUNG-IL PARK

Application No.:

Filed:

For: **Semiconductor Memory Device**

Art Group:

Examiner:

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR PRIORITY

Sir:

Applicant respectfully requests a convention priority for the above-captioned application, namely:

<u>COUNTRY</u>	<u>APPLICATION NUMBER</u>	<u>DATE OF FILING</u>
Republic of Korea	2003-98431	29 December 2003

☐ A certified copy of the document is being submitted herewith.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Dated: _____

2/27/04

12400 Wilshire Boulevard, 7th Floor
Los Angeles, CA 90025
Telephone: (310) 207-3800

Eric S. Hyman, Reg. No. 30,139

